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**BY EXPRESS MAIL ON**  
**October 26, 2001**  
**(EK 825 216 565 US)**

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Box PATENT APPLICATION  
ASSISTANT COMMISSIONER FOR PATENTS  
Washington, DC 20231

**RECORD OF TRANSMITTAL**

INVENTORS: (1) Takashi KAITO

TITLE: BEAM SHAPED FILM PATTERN FORMATION METHOD

DOCKET NO: S004-4433

S I R:

Kindly find enclosed herewith for filing the documents checked below. Any fees or charges not covered by the accompanying check should be charged to our Deposit Account No. 01-0268.

**APPLICABLE ITEMS CHECKED:**

XX PATENT APPLICATION (pages 1-8 of specification, 6 claims (page) 8 and abstract of the disclosure (page 9))

       DESIGN APPLICATION (specification, claim, declaration and power of attorney and photograph(s))

XX FORMAL DRAWINGS (  5   sheets) (NI A4)

       INFORMAL DRAWINGS (       sheets)

       RECORDATION FORM COVER SHEET and ASSIGNMENT  
(to be recorded and returned to the undersigned)

XX PRIORITY CLAIM - applicant(s) claim the benefit of  
priority of the following application(s):

Japanese Patent Appln. No. 2000-333368 filed Oct. 31, 2000

XX PRIORITY DOCUMENT(s)

       Enclosed

XX Not Enclosed

       VERIFIED STATEMENT TO ESTABLISH SMALL ENTITY STATUS

XX EXPRESS MAIL CERTIFICATION

       OTHER -

XX FEE

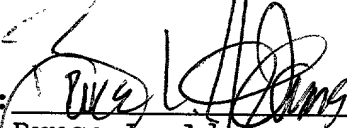
A check is enclosed for the following official fees:

	Large Entity	Small Entity
<u>XX</u> Basic Filing Fee	\$ 740.00	\$
<u>  0  </u> Independent Claims in Excess of 3	\$	\$
<u>  0  </u> Total Claims in Excess of 20	\$	\$
<u>      </u> Multiple Claim Fee	\$	\$
<u>      </u> Assignment Recordal Fee	\$	\$
TOTAL	\$ 740.00	\$

Respectfully submitted,

ADAMS & WILKS  
Attorneys for Applicant

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By:   
Bruce L. Adams  
Reg. No. 25,386

Re: New patent application of Takashi KAITO  
for BEAM SHAPED FILM PATTERN FORMATION METHOD

comprising transmittal letter, title, specification (pgs.1-8),  
6 claims (pg.8), abstract of the disclosure (pg.9), 5 sheets of  
formal drawings containing thereon Figs. 1A-5, express mail  
certification and check in the amount \$740.00

Attorney's Docket No: S004-4433

**EXPRESS MAIL CERTIFICATION UNDER 37 CFR §1.10**

Express Mail Tracking Number: **EK 825 216 565 US**

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Michael Ruas